



IFW

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**  
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.  
IOAP 4.1-1

In Re Application Of: **Anatoly L. Vikharev, Aleksey M. Gorbachev, Aleksandr G. Litvak, Yuriy V. Bykov, Grigory G. Denisov, Oleg A. Ivanov and Vladimir A. Koldanov**

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/526,800	03/07/2005	Kelly M. Stouffer	21036	1792	7409

Title: **HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE PLASMA AND DEVICE FOR CARRYING OUT SAID METHOD**

Address to:  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**37 CFR 1.97(b)**

1. ☒ The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

**37 CFR 1.97(c)**

2. ☐ The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

☐ the statement specified in 37 CFR 1.97(e);

**OR**

☐ the fee set forth in 37 CFR 1.17(p).

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APR 03 2008

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Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/526,800	03/07/2005		21036	1764	7409

Title: HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE PLASMA AND DEVICE FOR CARRYING OUT SAID METHOD

## Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of \_\_\_\_\_ is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 13-0610 as described below.
- ☐ Charge the amount of \_\_\_\_\_
- ☒ Credit any overpayment.
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- ☐ Payment by credit card. Form PTO-2038 is attached.

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March 31, 2008

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Tammi L. Taylor

Signature of Person Mailing Correspondence

Tammi L. Taylor

Typed or Printed Name of Person Mailing Certificate

\*This certificate may only be used if paying by deposit account.

Signature

Dated: March 31, 2008

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Anatoly L. Vikharev, Aleksey M. Gorbachev,  
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G. Denisov, Oleg A. Ivanov and Vladimir A.  
Koldanov

For : HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND  
FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE  
PLASMA AND DEVICE FOR CARRYING OUT SAID METHOD

COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

INFORMATION STATEMENT UNDER  
RULE 1.98

Enclosed is a copy of PCT International Application No.  
PCT/RU2003/000410 dated September 18, 2003, and the references  
cited. Translations of the Russian references are also enclosed.  
None of the references were considered as more than part of the  
general state of the art "A" in the PCT application.

Respectfully,

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Date: 3/31/08

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